

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/827,100	LI, LEHMANN K.
	Examiner	Art Unit
	KEVIN L. LEE	3753

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
33	501.08	7/5/2005	KL
600	594		
128	898		